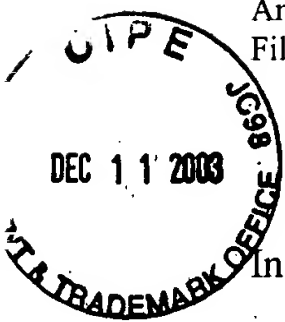


Appln. No.: 09/783,023  
Amendment dated December 11, 2003  
Filed with Appeal Brief



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

**Yoshiaki FUKUZUMI et al.**

Serial No.: 09/783,023

Filed: February 15, 2001

For: SEMICONDUCTOR DEVICE USING  
FUSE/ANTI-FUSE SYSTEM AND METHOD  
OF MANUFACTURING THE SAME

Atty. Docket No.: 001701.00059

Group Art Unit: 2823

Examiner: G. Fourson, III

Confirmation No.: 6061

**AMENDMENT AFTER FINAL REJECTION**

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

To place the application in better form for appeal, please amend the instant application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the Listing of Claims, which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.